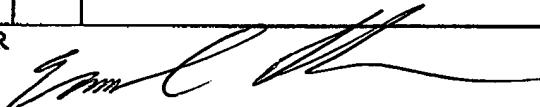


CORRECTED COPY

Sheet 1 of 1

FORM PTO-1449 (REV. 7-80)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. RD-25,905/USA		SERIAL NO. 09/639,636	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT <u>LIST OF ITEMS</u>				Applicant DAVID M. SHADDOCK			
				Filing Date 8/15/02		Group 1722	
U.S. PATENT DOCUMENTS CITED BY EXAMINER ON PTO 892							
*EXAMINER INITIAL	DOCUMENT NUMBER		DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
EL	A1	5231655	7-1993	WEI, ET AL	378	147	—
EL	A2	5198680	3-1993	KURAKAKE	378	147	—
EL	A3	5666722	9-1997	TAMM, ET AL	29	847	—
EL	A4	4929256	5-1990	SHEPHERD	51	293	—
U.S. PATENT DOCUMENTS CITED APPLICANT							
EL	AA	5557650	9/17/96	GUIDA, ET AL	—	—	—
EL	AB	5581592	12/03/96	ZARNOCH, ET AL	—	—	—
OTHER INFORMATION CITED BY APPLICANT (including Author, Title, Date, Pertinent Pages, etc.)							
EL	BA	AH SMITH, PHASE MASK MACHINING OR HIGH THROUGHPUT VIA FORMATION", LITEL INSTRUMENTS, PP. 1-6.					
EL	BB	B. SMOOTHER, "CYLINDRICAL LENS ARRAYS HOMOGENIZE EXCIMER BEAM", LASER FOCUS WORLD, NOVEMBER 1991, PP. 39.					
EL	BC	LAMBDA PHYSIK, "APPLICATION OF EXCIMER LASERS IN ELECTRONIC PACKAGING AND MANUFACTURING", LAMBDA PHYSIK INDUSTRIAL REPORT, 5/96, PUBLICATION NO. 10, PP. 1-8.					
EXAMINER 					DATE CONSIDERED 4/24/03		
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant							